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CHROMIUM ELECTROPLATING AND ANODIZING AIR GENERAL PERMIT NOTIFICATION FORM Part III. Notification of Intent to Use General permit	<i>j</i>
CHROMIUM ELECTROPLATING AND ANODIZING AIR GENERAL PERMIT NOTIFICATION FORM Part III. Notification of Intent to Use General permit Prior to filling out this form, please read the instructions provided at the end of the form for your files	50
Prior to filling out this form, please read the instructions provided at the end of the form. Send completed form to the address listed in the instructions and keep a copy of the form for your files.	
Facility Name and Location	
1. Facility Owner/Company Name (Name of corporation, agency, or individual owner):	
Mirror Finish & Polish	
2. Site Name (For example, plant name or number):	
UMT Warehouse	
3. Hazardous Waste Generator Identification Number:	
FLR000122788	
4. Facility Location: Street Address: 25/6 UMT Industrial Drive Suite 109	
Street Address: 2514 UMT Industrial Drive Suite 109 City: 10001. County: Orange Zip Code: 2000 2	
1 Hooka 32703	
5. Facility Identification Number (DEP Use ONLY - do not fill in):	
是一个人,我们就是一个人,我们就是一个人的人,我们就是一个人的人的人,也不是一个人的人的人,也不是一个人的人的人,也不是一个人的人的人,也不是一个人的人的人,也	
Responsible Official	
6. Name and Title of Responsible Official:	
Name: Charlie Chang Title: Plant Monger.	
7. Responsible Official Mailing Address:	
Organization/Firm: 7411 RIVEYS (de P/	
City: Orlando El County: Orange Zip Code: 32810	
8. Responsible Official Telephone Number:	
Telephone: (407)342 - 9095 Fax: () -	
Facility Contact (If different from Responsible Official) 9. Name and Title of Facility Contact (For example, plant manager):	
10. Facility Contact Address:	
Street Address: 1376 San diego Ct.	
City: Windersprings flowing Seminal Zip Code: 32708	
11. Facility Contact Telephone Number:	
Telephone: (401)797 - 4518 Fax: () -	

DEP Form No. 62-213.900(5)

Effective: 2/24/99

Facility Information

1.a. Provide the information below for each hard electroplating machine at the facility. Indicate the type of machine, the date of its purchase, and the date the control device was installed, if applicable.

HARD CHROMIUM PLATING TANKS

DATE //	UNIT CLASS			APPLICABLE
PURCHASED	(circle one)	DEVICE	DEVICE	STANDARD
(12 / O	O	INSTALLED	(see key)	(see key)
	New/Existing			
	New/Existing			
	New/Existing			
•	New/Existing			
	New/Existing			
	New/Existing		·	
	New/Existing			

New/Existing	
Key for Control Device Type	Applicable Standard Key
PBS = packed-bed scrubber CMP = composite mesh pad PBS/CMP = packed-bed scrubber and composite mesh pad FS = fume suppressant only FS/WA = fume suppressant with a wetting agent FM = fiber-bed mist eliminator WA = wetting agent	a = 0.03 mg/dscm b = 0.015 mg/dscm c = alternative standard for multiple tanks under common control
Is the facility's cumulative potential rectifier capacity greater Yes No	than 60 million ampere-hours per year?
1.b. Provide the information below for each decorative electron Indicate the type of machine, the date of its purchase, ar	

DECORATIVE AND ANODIZING TANKS

DATE	UNIT CLASS	DATE CNTRL	CONTROL	APPLICABLE
PURCHASED	(circle one)	DEVICE	DEVICE	STANDARD
		INSTALLED	(see key)	(see key) 1,/
5-25-05		11.1.05	WA/FS	4/7
	New/Existing		1.	
	New/Existing			
	New/Existing			
	New/Existing			
·	New/Existing			
	New/Existing			

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applicable.

Key for Control Device Type		Applicable Standard Key	
PBS = packed-bed scrubber CMP = composite mesh pad PBS/CMP = packed-bed scrub FS = fume suppressant only FS/WA = fume suppressant w FM = fiber-bed mist eliminate WA = wetting agent	ith a wetting agent	x = 0.01 mg/dscm y = 45 dynes/cm z = records of bath components (trivalent Cr tanks only) c = alternative standard for multip under common control	ole tanks
•	both hard and decora	the requirements of paragraph (5) of Part II ative plating or anodizing units, you must che January 25, 1997	
January 23,	1990	January 23, 1997	
3. Indicate how the facility wi	ll fulfill the complian	ce demonstration:	
[X] The facility	will conduct an initial	performance test	
The facility tension limit	will use a wetting ager in No. 1 above.	nt to reduce emissions and will meet the exis	ting surface
4. Equipment Monitoring and Check all logs which are requi		mation in accordance with the requirements of this	general permit:
(a) Equipment maintenance	ιX	(b) Equipment inspection and repair	\mathcal{L}
(c) Equipment malfunctions	<u></u>	(d) Operation and maintenance checklist	نا
(e) Instrument calibration (used during initial performance)	ce test)	(f) Start-up, shutdown, malfunction plan	
(g) Performance test results		(h) Equipment monitoring	
(i) Excess emissions		(j) Operating periods	[X]
(k) Rectifier capacity		(l) Fume suppressant records	نيز ا
(m) Purchase records of wettin	g agent components	LXΙ	, .
5. Surrender of Existing DEP	Air Permit(s)		
Please indicate with an "X" th	e appropriate selection	n:	•
notification form;	the permit number(s)		
No DEP air perm	its currently exist for	the operation of the facility indicated in this	notification form.

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Responsible Official Certification

I, the undersigned, am the responsible official, as defined in Part II of this form, of the facility addressed in this notification. I hereby certify, based on information and belief formed after reasonable inquiry, that the statements made in this notification are true, accurate and complete. Further, I agree to operate and maintain the air pollutant emissions units and air pollution control equipment described above so as to comply with all terms and conditions of this general permit as set forth in Part II of this notification form.

I will promptly notify the Department of any changes to the information contained in this notification.

Print name of responsible official

Signature

Date

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